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Docket No. 0819-0637

2813  
# 7  
5/22/02  
Harrison

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

Yoshihiro MORI et al.

Serial No. 09/942,038

Filed: August 30, 2001

For: CAPACITOR AND METHOD FOR  
FABRICATING  
SEMICONDUCTOR DEVICE

) Group Art Unit:

) Examiner:

CERTIFICATE OF MAILING

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RESPONSE TO ELECTION REQUIREMENT

el. 10-15 w/d

Honorable Commissioner for Patents

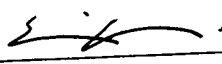
Washington, D.C. 20231

Sir:

In response to the election requirement in the Office Action of March 26, 2002,  
Applicants hereby elect without traverse the Group II claims - that is, claims 10-15, drawn to  
method for fabricating a semiconductor device.

Examination on the merits is requested.

Respectfully submitted,

  
Eric J. Robinson  
Registration No. 38,285

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 770-9300

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